

Atty. Dkt. No. AMAT/2592.C9/DSM/LOW K/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:
Gaillard, et al.

Serial No.: 10/789,209

Confirmation No.: 9101

Filed: February 27, 2004

For: Method of Decreasing the
K Value in SIOC Layer
Deposited by Chemical
Vapor Deposition

Group Art Unit: 2818

Examiner: David Nhu

MAIL STOP ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on 6/7, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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AMENDMENT AFTER ALLOWANCE

Following mailing of a Notice of Allowance on May 9, 2005, Applicants request entry of the following amendments. **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.